



# CERTIFICATE OF MAILING

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Kent E. Genin  
Name of Applicant, Assignee or  
Registered Representative  
*[Signature]*  
Signature  
3/26/2001  
Date of Signature

Our Case No. 7103/30-2

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Taleh et al.  
Serial No. 08/853,323  
Filing Date: May 8, 1997  
For LINEAR POLISHER AND METHOD  
FOR SEMICONDUCTOR WAFER  
PLANARIZATION

Examiner: G. Nguyen  
Group Art Unit No. 3723  
Batch No. A29

## LETTER TO OFFICIAL DRAFTSMAN

Commissioner for Patents  
Washington, D.C. 20231

Attn: Official Draftsman

Dear Sir:

Please substitute the enclosed 7 sheets of formal drawings for the previously submitted drawings.

Respectfully submitted,

*[Signature]*

Kent E. Genin, Reg. No. 37,834  
Attorney for Applicants

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